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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of

MICHAEL SHU-HUAN WANG ET AL.

Serial No. 10/718,921 (TI-34402)

Filed November 21, 2003

For: CHEMICAL-MECHANICAL POLISHING APPARATUS AND METHOD TO  
MINIMIZE SLURRY ACCUMULATION AND SCRATCH EXCURSIONS

Art Unit 2399

Examiner SHANTESE L. McDONALD

Customer No. 23494

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8**

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7-28-06

Jay M. Cantor, Reg. No. 19,906

**AMENDMENT UNDER 37 C.F.R. 1.111**

In response to the Office action dated June 2, 2006, please amend the above  
identified application as follows: